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TERNARY COMPOUND THIN FILM SOLAR CELLS

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The investigation of a group of ternary compound semiconductor (I-III-VI₂) thin films for future applications in photovoltaic devices is proposed. The consideration of these materials (CuInSe₂, CuInTe₂ and especially CuInS₂) for long-range device development is emphasized. The major objectives of this research include: (1) The identification and production of device-quality thin films of CuInS₂ on suitable substrates; (2) The demonstration of homojunction viability for CuInS₂ thin film solar cells; (3) The growth and characterization of CuInSe₂ and CuInTe₂ for photovoltaic application; and, (4) Possible heterojunction demonstration (e.g. p-type CuInSe₂ / n-type CdS thin film solar cell).

Much of the activity to date has been concerned with the growth and properties of CuInX₂ films. X-ray (Figs. 4-9) and electron diffraction analyses, Hall mobility and coefficient (Figs. 10, 13), resistivity and carrier concentration variations with substrate and film temperature (Fig. 11), as well as grain size data (Fig. 12) have been determined. Both p- and n-type films of CuInS₂ and CuInSe₂ have been produced. Single and double source deposition techniques have been utilized. Some data have been recorded for annealed films. (e.g. CuInS₂ in H₂S/Ar).

The physical and electrical characterizations of these films are to continue. Photoconductivity data and lifetime measurements are scheduled. A three-source deposition technique is being developed. Films are to be deposited onto several metal substrates, and a thorough investigation of contacts to the ternary films is underway. A tentative schedule (Fig. 15) accompanies this text.

The key results to date include:

- (1) The deposition of CuInS_2 , CuInSe_2 and CuInTe_2 films.**
- (2) Production of n- and p-type CuInS_2 and CuInSe_2 films on alumina substrates.**
- (3) Development of a double source deposition technique for CuInS_2 .**
- (4) Report of electrical properties of CuInS_2 films.**
- (5) Report of x-ray and electron diffraction studies on ternary compound films.**

FIGURE CAPTIONS

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- Fig. 2.** Objectives
- Fig. 3.** Activity-To-Date
- Fig. 4.** Chalcopyrite Structure
- Fig. 5.** Calculated X-Ray Pattern: CuInS_2
- Fig. 6.** Calculated X-Ray Pattern: CuInSe_2
- Fig. 7.** Calculated X-Ray Pattern: CuInTe_2
- Fig. 8.** Tabulated X-Ray Data: CuInS_2
- Fig. 9.** Comparison of Single Phase and Multiple Phase Thin Films of CuInS_2 (X-Ray Diffraction Data)
- Fig. 10.** Mobility Dependence on Inverse Temperature. (a) Single Source Method, $T_{\text{sub}} = 280^\circ\text{C}$; (b) Single Source Method, $T_{\text{sub}} = 160^\circ\text{C}$; (c) Single Source Method, $T_{\text{sub}} = 400^\circ\text{C}$. (d) - (i) Double Source Method. (d) $T_{\text{sub}} = 180^\circ\text{C}$, $T_{\text{sulphur}} = 92^\circ\text{C}$; (e) $T_{\text{sub}} = 220^\circ\text{C}$, $T_{\text{sulphur}} = 92^\circ\text{C}$; (f) $T_{\text{sub}} = 320^\circ\text{C}$, $T_{\text{sulphur}} = 92^\circ\text{C}$; (g) $T_{\text{sub}} = 400^\circ\text{C}$, $T_{\text{sulphur}} = 92^\circ\text{C}$; (h) $T_{\text{sub}} = 400^\circ\text{C}$, $T_{\text{sulphur}} = 102^\circ\text{C}$; (i) $T_{\text{sub}} = 400^\circ\text{C}$, $T_{\text{sulphur}} = 108^\circ\text{C}$. Film Thicknesses are 0.5μ ; Substrates are Alumina.
- Fig. 11.** Resistivity and Carrier Concentration Dependence on Inverse Temperature. Curves (d') and (d'') Correspond to Curve (d) on Fig. 10. ($T_{\text{sub}} = 180^\circ\text{C}$). Curves (g') and (g'') Correspond to Curve (g) on Fig. 10. ($T_{\text{sub}} = 180^\circ\text{C}$).
- Fig. 12.** Grain Size Dependence on Substrate Temperature for Various Substrate Materials.
- Fig. 13.** Hall Coefficient as a Function of Substrate Temperature for Two Source Method. (a) $T_{\text{sulphur}} = 88^\circ\text{C}$; (b) $T_{\text{sulphur}} = 92^\circ\text{C}$; (c) $T_{\text{sulphur}} = 102^\circ\text{C}$.
- Fig. 14.** Summary of Film Properties.
- Fig. 15.** Planned Activity.

TITLE PAGE

- (a) TERNARY COMPOUND THIN FILM SOLAR CELLS**
- (b) University of Maine at Orono**
- (c) September 1, 1975 - August 31, 1976 (requested)**
- (d) \$34,929. (requested)**
- (e) Lawrence L. Kazmerski
Associate Professor
Department of Electrical Engineering**

Fig. 1.

OBJECTIVES

- 1 . The Identification and Production of Device - Quality Thin Films of CuInS_2 .**
- 2. Demonstration of Homojunction Viability for CuInS_2 Thin Film Solar Cells .**
- 3. Growth and Investigation of Other CuInX_2 Materials .**
- 4. Possible Heterojunction Demonstration .**

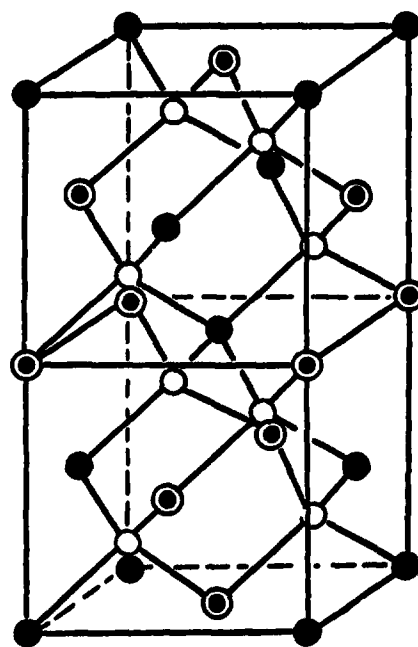
Fig. 2.

ACTIVITY-TO-DATE

1. CuInS₂
 - (a) Development of Single and Double Source Deposition Techniques.
 - (b) X-ray and Electron Diffraction Studies.
 - (c) Initial Electrical Characterization of Films (μ , σ , n).
 - (d) Production of n and p-type Films.
 - (e) Recrystallization.

2. CuInSe₂, CuInTe₂
 - (a) Film Deposition Crystallization.
 - (b) Electrical Characterization.
 - (c) X-ray, Electron Diffraction Analyses.

Fig. 3.



●Cu ●In ○S

Fig. 4.

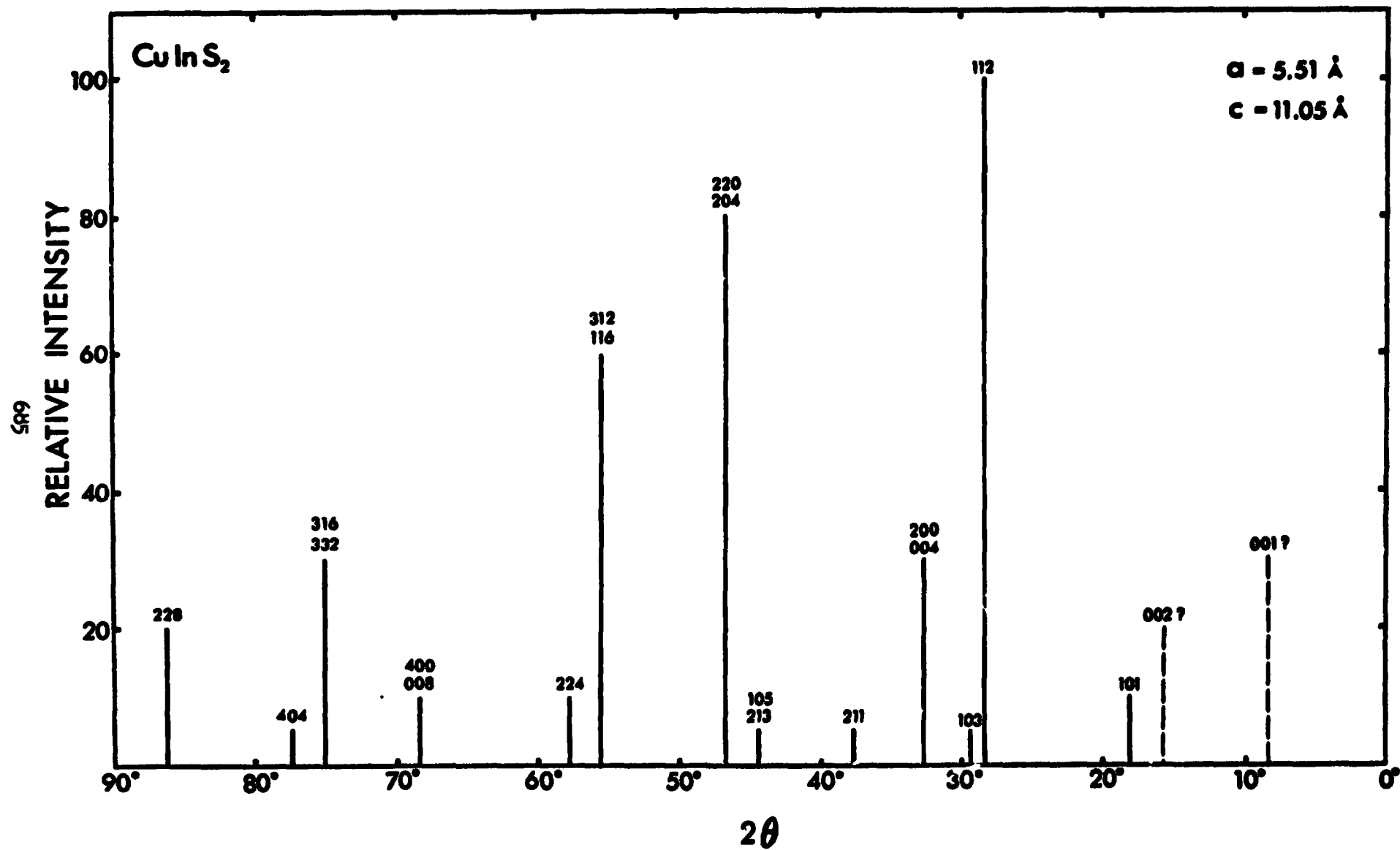


Fig. 5.

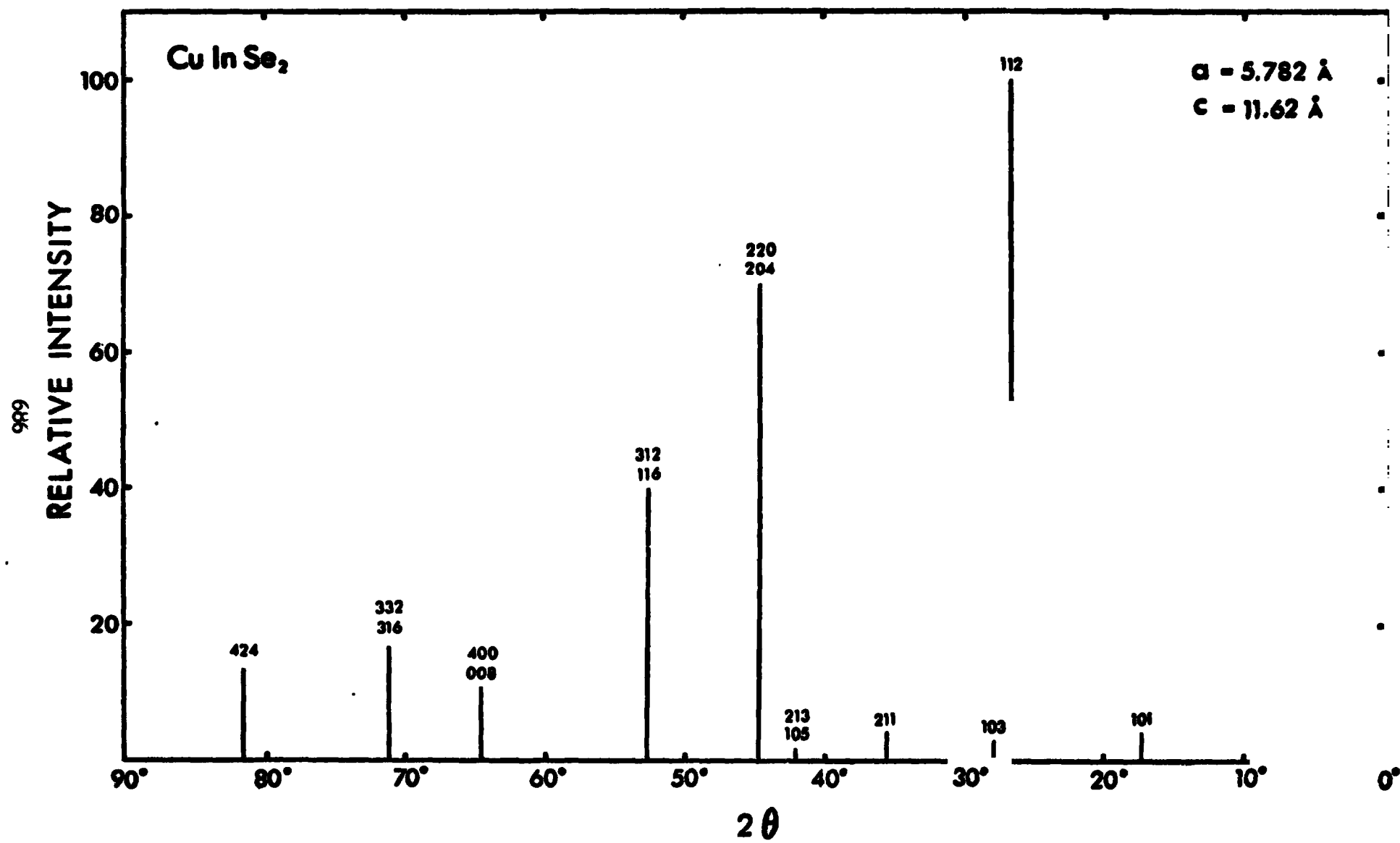


Fig. 6.

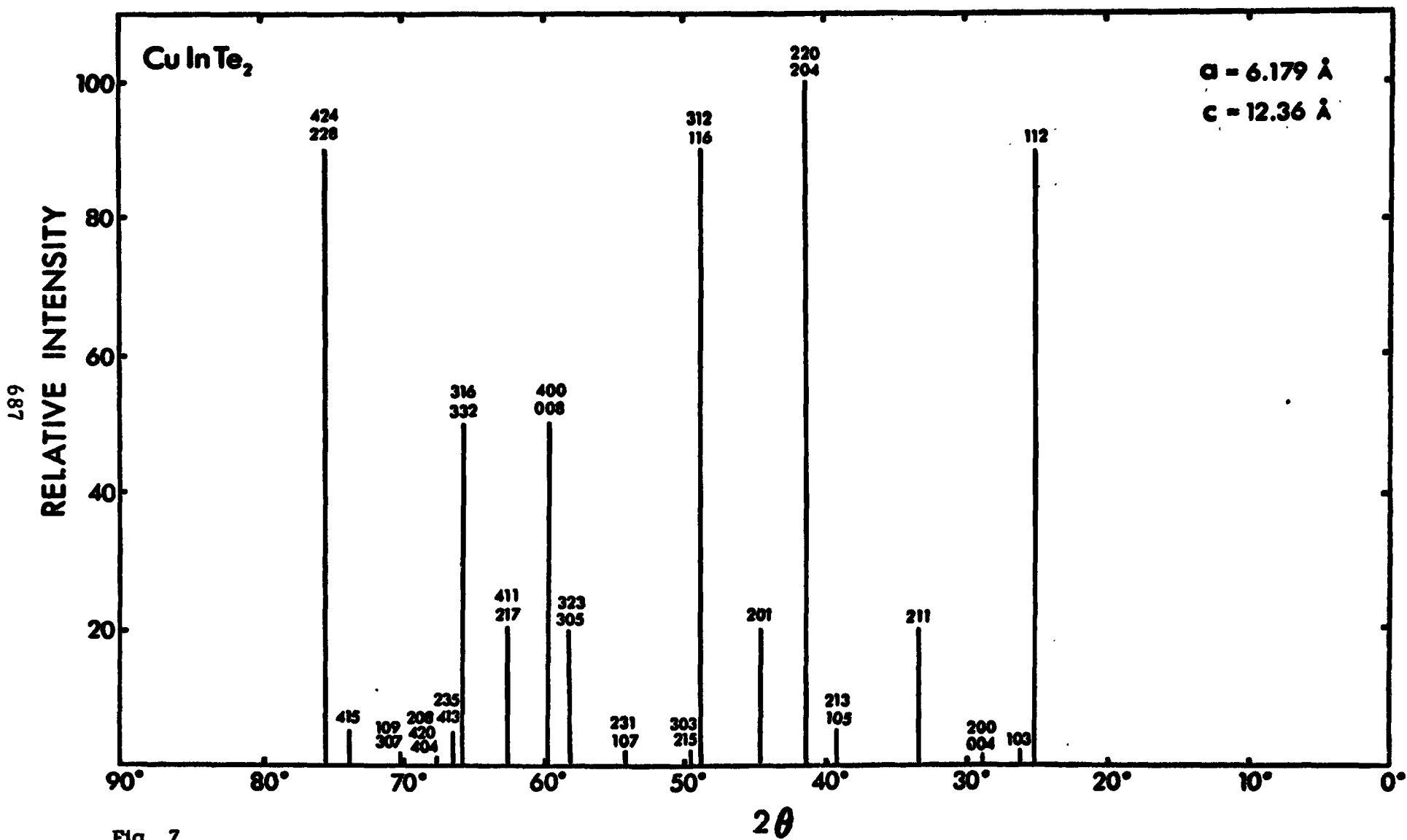


Fig. 7.

TABLE II.

X-ray Diffraction Data (Calculated and Experimental Values)
For CuInS_2 Powders and Thin Films.
(Cu $K\alpha$ and Cr $K\alpha$ Radiation)

CALCULATED			hkl	Relative Intensity	OBSERVED		
d	2θ				Powder	2θ	
	CuKa	CrKa				CuKa	Film CrKa
10.6	8.34°		001?	30	--	--	--
5.56	15.94°		002?	20	--	--	--
4.87	18.20°	27.21°	101	10	18.16°	18.20°	27.2°
3.16	28.24°	42.51°	112	100	28.18°	28.18°	42.4°
3.04	29.38°	44.27°	103	5	29.28°	29.25°	44.2°
2.74	32.68°	49.42°	200,004	30	32.60°	32.60°	49.4°
2.39	37.64°	57.28°	211	5	37.52°	37.50°	57.2°
2.04	44.42°	68.32°	213,105	5	44.36°	44.22°	68.2°
1.94	46.84°	72.38°	220,204	80	46.66°	46.60°	72.3°
1.66	55.36°	87.27°	312,116	60	55.30°	55.28°	87.16°
1.591	57.98°	92.10°	224	10	57.88°	57.86°	92.1°
1.266	65.04°	129.6°	316,332	30	64.92°	64.90°	--
1.128	86.24°	--	228	20	--	--	--

Fig. 8.

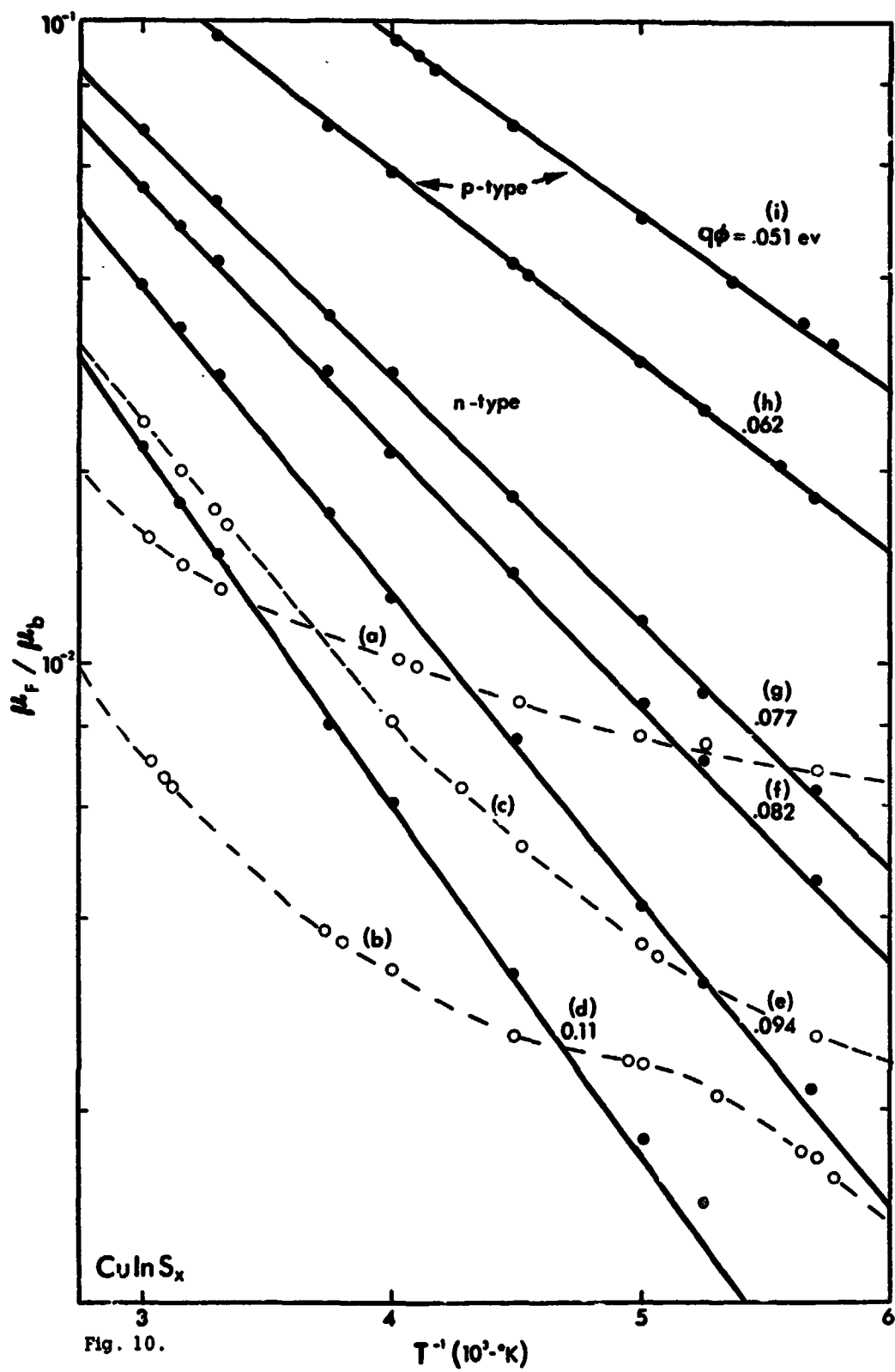


Fig. 10.

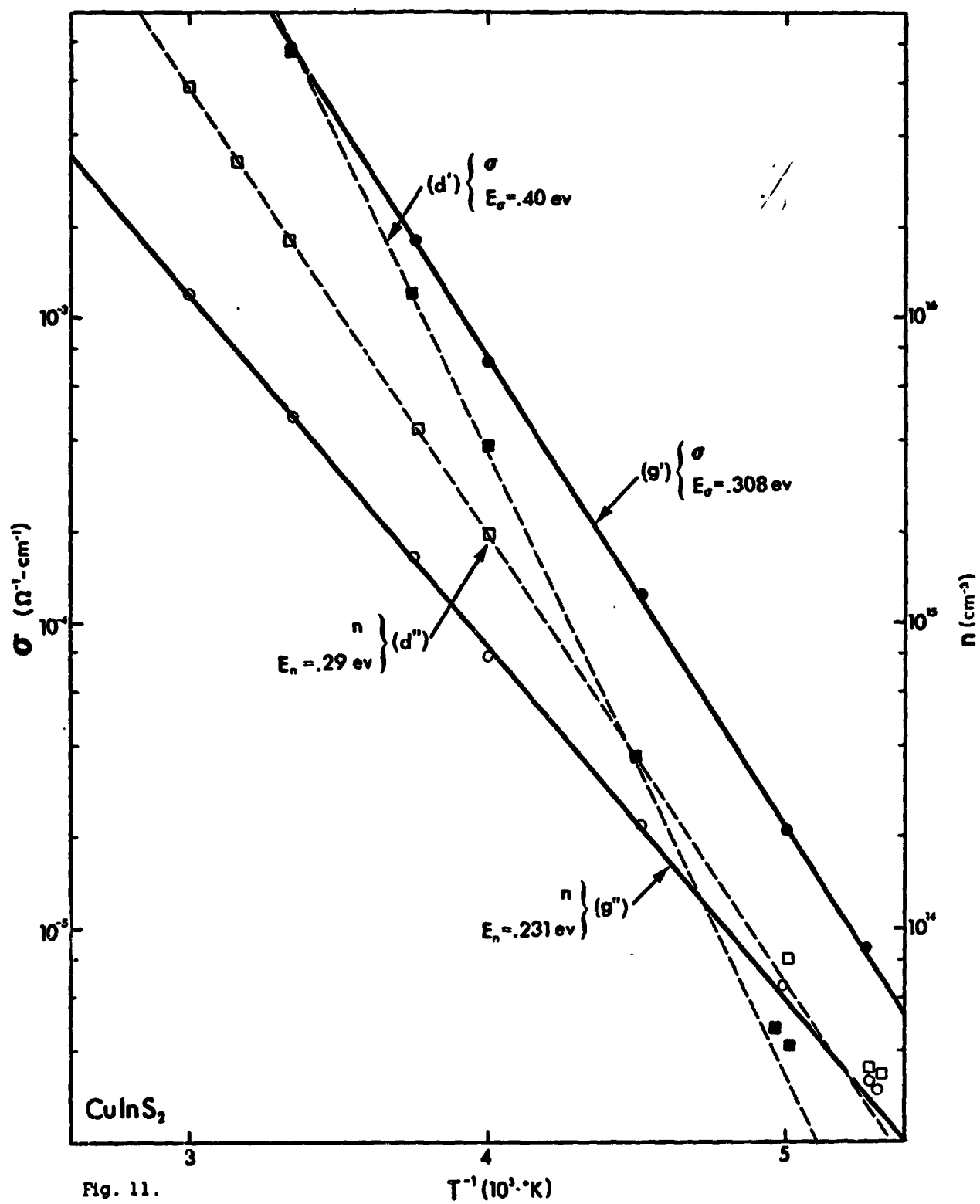


Fig. 11.

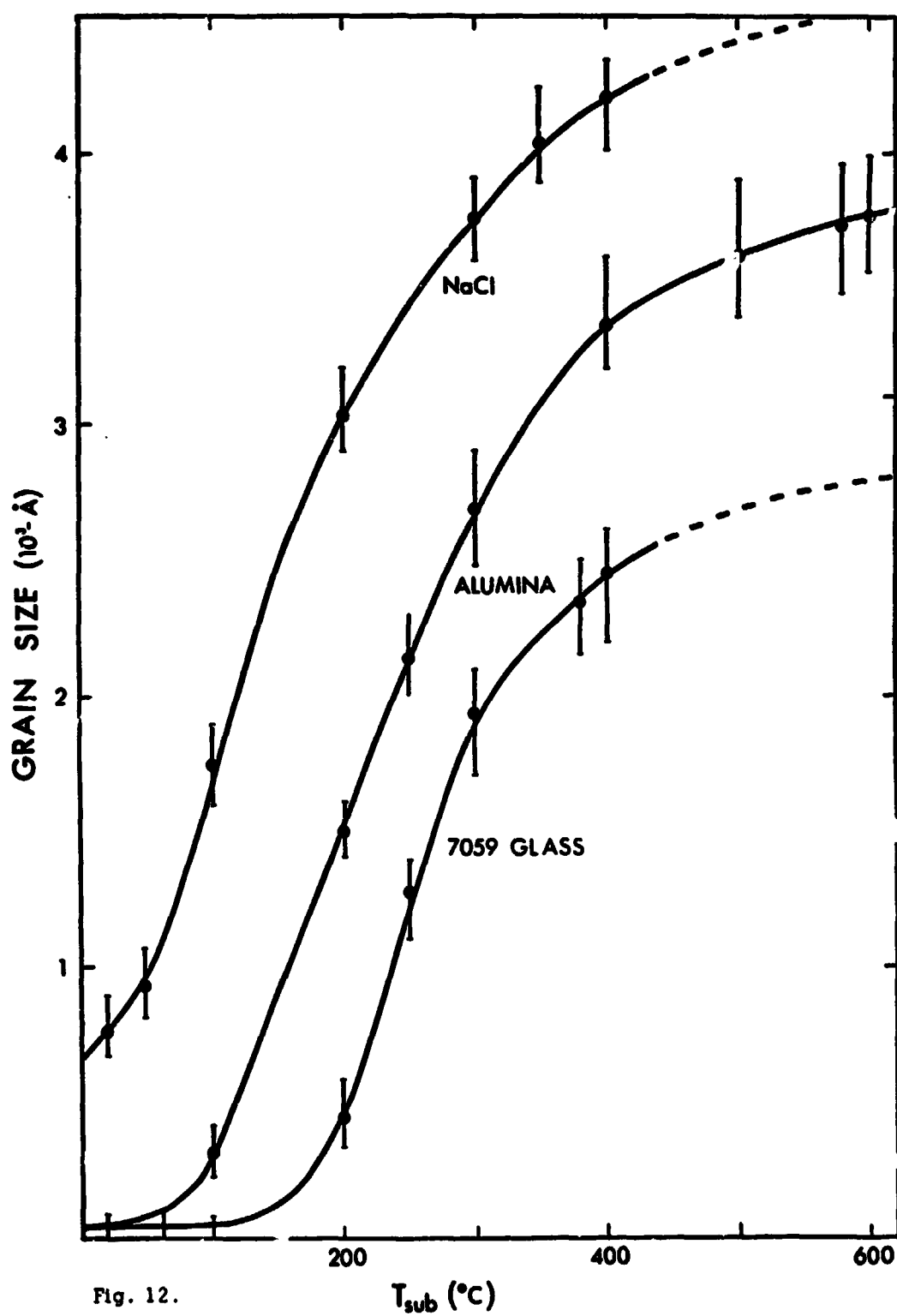


Fig. 12.

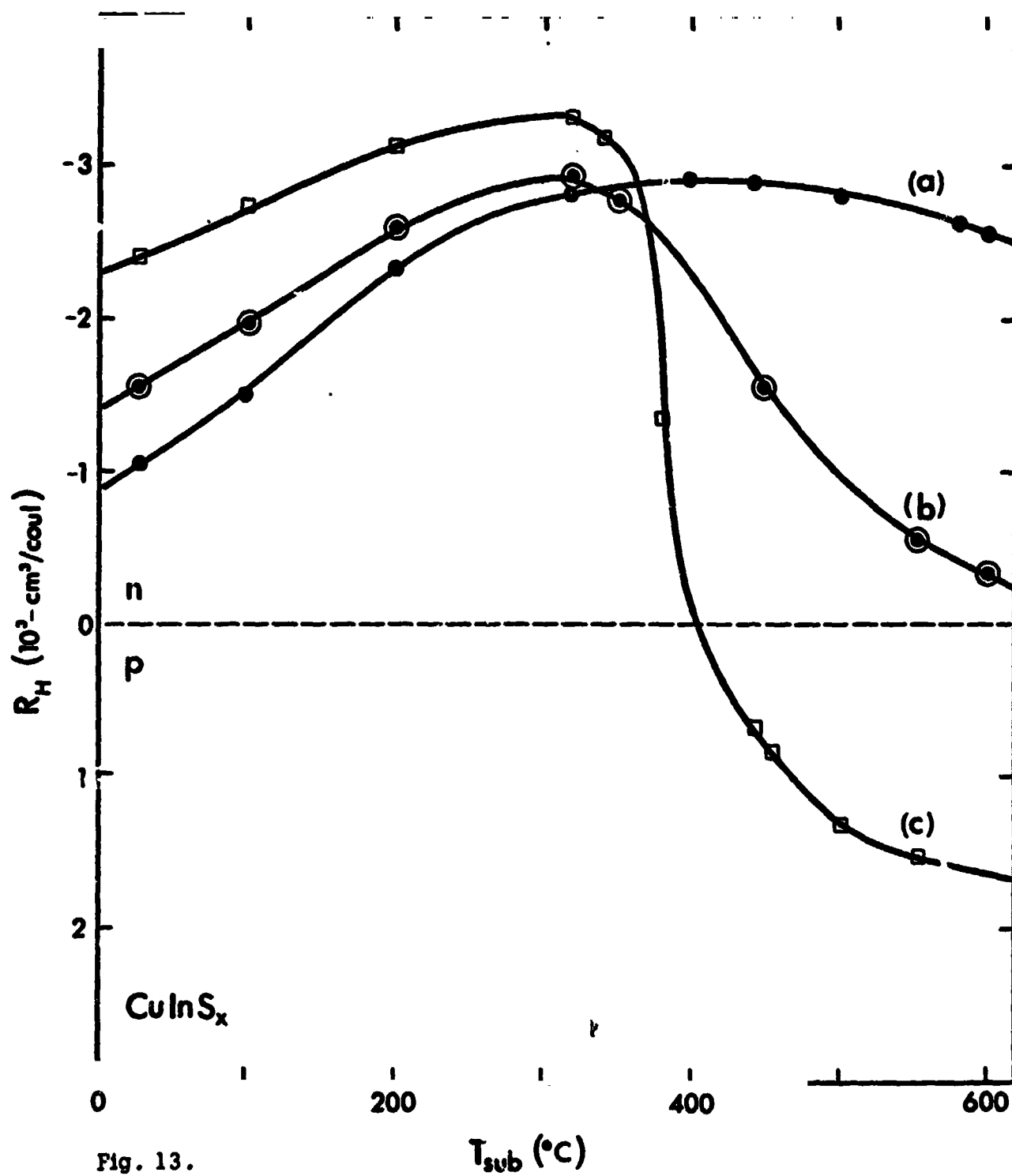


Fig. 13.

Table I. Comparison of properties of the deposited CuInS_2 thin films on this study with Single Crystal Values.

		Single Crystals (a), (b)				Films		
		ρ	n, p	μ	E_g	ρ	n, p	μ
		($\Omega\text{-cm}$)	(cm^{-3})	($\frac{\text{cm}^2}{\text{v-sec}}$)	(eV)	($\Omega\text{-cm}$)	(cm^{-3})	($\frac{\text{cm}^2}{\text{v-sec}}$)
CuInS_x	n	1	3×10^{16}	200	1.55	0.1-800	$10^{14}-10^{19}$	1-10; 28 ^(c)
	p	5	1×10^{17}	15		.8-400	$10^{13}-10^{16}$	$\sim 2; 3.2^{(c)}; 8.3^{(d)}$

(a) B. Tell, J. Shay and H. Kasper, Phys. Rev. B, 4, 2463 (1971)

(b) B. Tell and H. Kasper, Phys. Rev. B, 4, 4455 (1971).

(c) Recrystallized in H_2S , initially n-type.

(d) Recrystallized in H_2S , initially p-type.

Fig. 14.

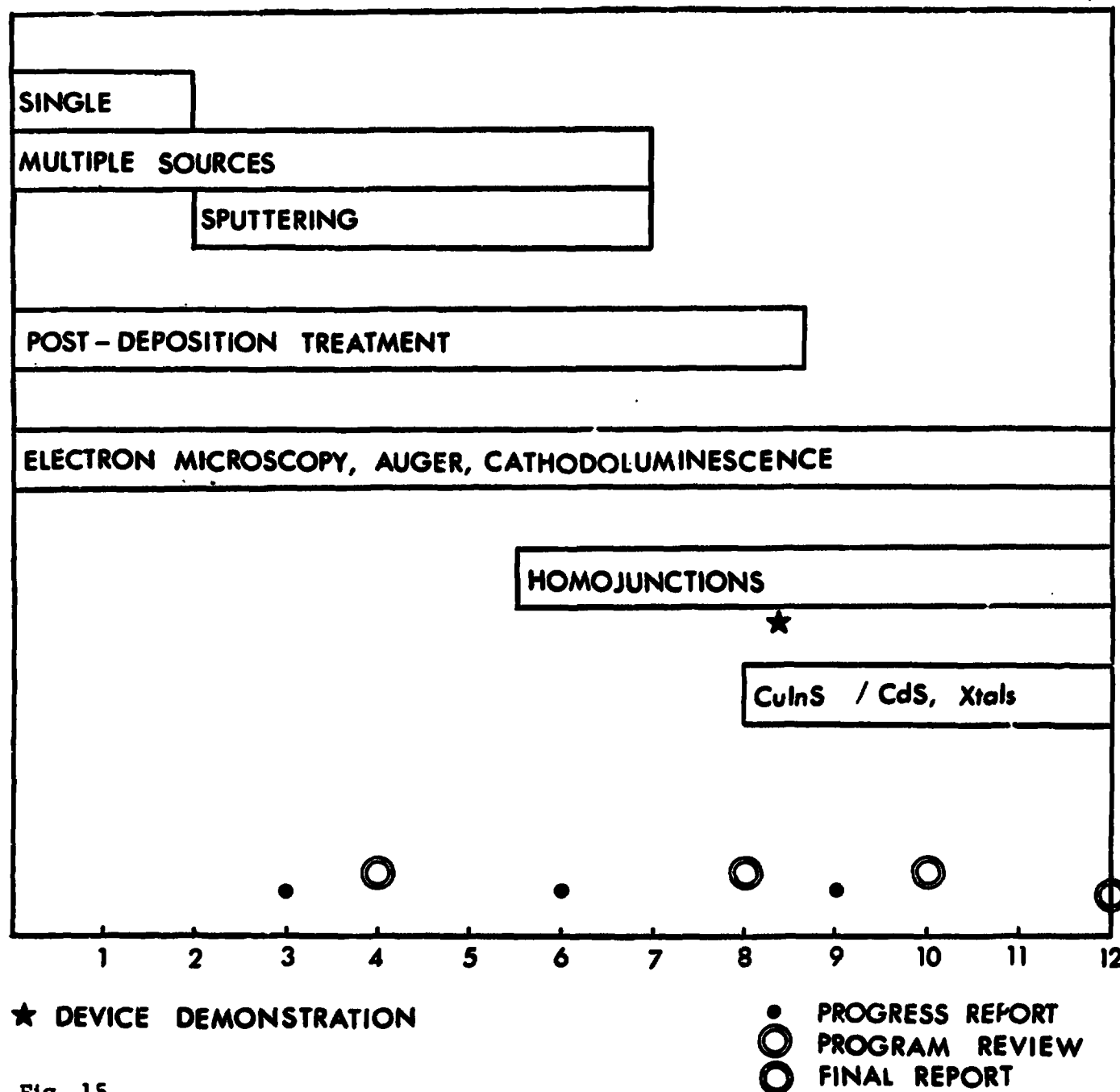


Fig. 15.